

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : National Phase Entry of PCT/DE2004/002160
Applicant : Dieter HUHSE et al
Filed : March 23, 2006
TC/A.U. :
Examiner :

Docket No. : 3286-103
Customer No. : 6449
Confirmation No.:

INFORMATION DISCLOSURE STATEMENT

Director of the United States Patent
and Trademark Office
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

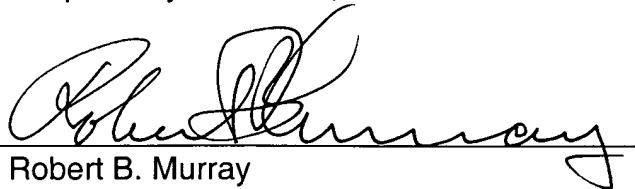
In compliance with applicants duty of disclosure under 37 C.F.R. 1.56, enclosed is a copy of the International Search Report in the corresponding international application. The relevance of some the references is noted in the International Search Report and copies of the references are provided herewith for Examiner's review.

US 2004/0051926A1 is the English Equivalent of DE 100 47 170 A1.

Please charge any fee deficiency or credit any overpayment to Deposit Account No. 02-2135.

Respectfully submitted,

By



Robert B. Murray
Attorney for Applicants
Registration No. 22,980
ROTHWELL, FIGG, ERNST & MANBECK, p.c.
Suite 800, 1425 K Street, N.W.
Washington, D.C. 20005
Telephone: (202)783-6040

RBM/cb

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				<i>Complete if Known</i>	
				Application Number	New Application
				Filing Date	March 23, 2006
				First Named Inventor	Dieter HUHSE et al
				Group Art Unit	
				Examiner Name	
				Confirmation No.	
Sheet	1	of	3	Attorney Docket Number	3286-103

[illegible]

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				<i>Complete if Known...</i>	
				Application Number	New Application
				Filing Date	March 23, 2006
				First Named Inventor	Dieter HUHSE et al
				Group Art Unit	
				Examiner Name	
				Confirmation No.	
Sheet	2	of	3	Attorney Docket Number	3286-103

[illegible]

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

14322

2006

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				<i>Complete if Known</i>	
				Application Number	New Application
				Filing Date	March 23, 2006
				First Named Inventor	Dieter HUHSE et al
				Group Art Unit	
				Examiner Name	
				Confirmation No.	
Sheet	3	of	3	Attorney Docket Number	3286-103

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²	
	12.	Schimpe et al., "Characterisation of Frequency Response of 1.5 MUM INGAASP DFB Laser Diode and INGAAS...", ELECTRONICS LETTERS, vol. 22, no. 9, April 24, 1986, pgs. 453-454.		
	13.	Reimann et al., "Advanced semiconductor laser based electro-optical sampling system using soliton pulse compression for direct probing at 1.55-/spl mu/m wavelength", LASERS AND ELECTRO-OPTICS SOCIETY ANNUAL MEETING, 1988, vol. 1, December 1, 1998, pgs. 215-216.		
	14.	Reimann et al., "Low jitter dual semiconductor laser system using electrical phase shift for fast temporal scanning in time-resolved pump and probe experiments", LASERS AND ELECTRO-OPTICS, 1999, vol. 2, August 30, 1999, pgs. 203-204.		
Examiner Signature				Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.